



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 30, 2025

IGI Report Number **LG724596229**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PRINCESS CUT**

Measurements **6.93 X 6.79 X 4.88 MM**

GRADING RESULTS

Carat Weight **2.05 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

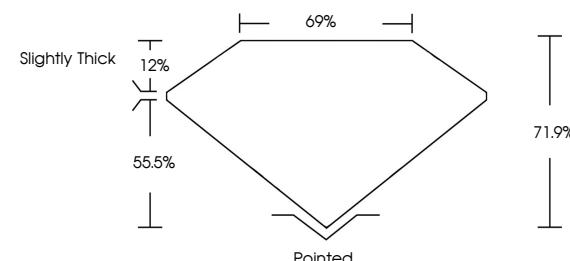
Symmetry **EXCELLENT**

Fluorescence **NONE**

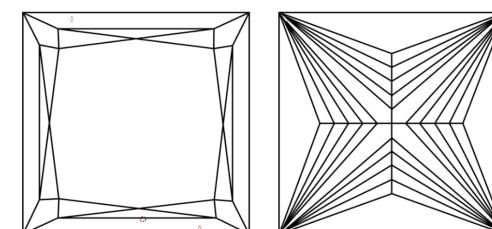
Inscription(s) **IGI LG724596229**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

www.igi.org

LG724596229
Report verification at igi.org

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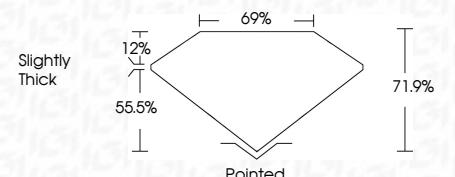
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Sample Image Used



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July 30, 2025	IGI Report No. LG724596229	PRINCESS CUT	2.05 CARATS	E	VVS 2	71.9%	69%	Slightly Thick	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG724596229
					Color Grade								
					Clarity Grade								
					Depth								
					Table Grade								
					Culet								
					Polish								
					Symmetry								
					Fluorescence								
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